

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

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Docket Number (Optional)

SON-0522US

Application Number

10/003,085

Applicant(s)

Keiichi Hayashi

Filing Date

December 6, 2001

Group Art Unit

2179

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
XLB		2000-278371	6/10/2000	Japan			abs	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

XLB		Japanese Office Action dated October 26, 2004 and partial English translation.

EXAMINER

XL - Bautista

DATE CONSIDERED

5/5/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.